

02.022497.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
KIYOFUMI SAKAGUCHI, ET AL.) : Examiner: T. Le
Application No.: 10/687,743) : Group Art Unit: 2814
Filed: October 20, 2003) :
For: THIN-FILM SEMICONDUCTOR) :
DEVICE AND METHOD OF) :
MANUFACTURING THE) :
SAME) : Date: January 13, 2005

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the foreign patent documents are enclosed.

The listed documents were cited in a Search Report in a corresponding European application. A copy of the Search Report, which is dated November 29, 2004, is enclosed. Also enclosed is an English-language abstract for Japan 55-145354.

Japan 9-312349, which is cited in the Search Report, is already of record in the subject application.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

January 13, 2005
(Date of Deposit)

Damond E. Vadnais, Reg. No. 52,310
(Name of Attorney for Applicant)

Signature

January 13, 2005
Date of Signature

STATEMENT UNDER 37 C.F.R. § 1.97(e)

Each item of information in this Information Disclosure Statement was first cited in any communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing date of this Statement.

FORMAL MATTERS

No fee is believed due; however, any fee required in connection with this paper should be charged to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our Costa Mesa, California office by telephone at (714) 540-8700. All correspondence should continue to be directed to our address given below.


Respectfully submitted,



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FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)		ATTY DOCKET NO. 00862.022497.1		APPLICATION NO. 10/687,743	
Date Submitted: January 13, 2005		APPLICANT KIYOFUMI SAKAGUCHI, ET AL.			
		FILING DATE October 20, 2003		GROUP 2814	



U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	5,597,766	01/28/1997	Neppl	437	226		
	5,888,882	03/30/1999	Igel, et al.	438	460		
	6,017,804	01/25/2000	Freund, et al.	438	460		

FOREIGN PATENT DOCUMENTS							
DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT		
0 603 973 A2	06/29/1994	Europe					
WO 93/21663	10/28/1993	PCT					
55-145354	11/12/1980	Japan			Abstract		

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)	

EXAMINER	DATE CONSIDERED
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.